

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))					Docket No. 050685-US
Re Application Of: Koenenkamp <small>U.S. PATENT & TRADEMARK OFFICE</small>					
Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/532,190	21 April 2005		30234		
Title: Field Effect Transistor and Method of Its Fabrication					
Address to: Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450					
37 CFR 1.97(b)					
1. <input checked="" type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.					
37 CFR 1.97(c)					
2. <input type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:					
<input type="checkbox"/> the statement specified in 37 CFR 1.97(e); OR <input type="checkbox"/> the fee set forth in 37 CFR 1.17(p).					

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
(Under 37 CFR 1.97(b) or 1.97(c))

JUN 29 2005

Docket No.
050685-US

PTO-146
Filing Application
RECEIVED
U.S. PATENT & TRADEMARK OFFICE

Koenenkamp

Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/532,190	21 April 2005		30234		

Title: Field Effect Transistor and Method of Its Fabrication

Payment of Fee

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

- A check in the amount of _____ is attached.
- The Director is hereby authorized to charge and credit Deposit Account No. as described below.
 - Charge the amount of _____
 - Credit any overpayment.
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- Payment by credit card. Form PTO-2038 is attached.

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27 June 2005

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Karl Hormann

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Signature

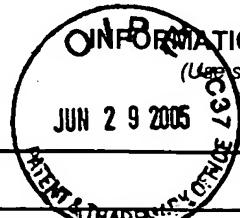
Signature

Dated: 27 June 2005

Karl Hormann
Registration No.: 26,470

Tel.: 617-491-8867

CC:



INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

JUN 29 2005

ATTY DOCKET NO
050085-US

APPLICATION NO
10/532,190

APPLICANT(S)
Koenenkamp

FILING DATE
21 April 2005

GROUP ART UNIT

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
A	6,515,325 B1	2/2003	Farnsworth et al.	257	530	

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AA	2002/0001905 A1	1/3/2002	Choi et al.	438	268	
BB	2003/0132461 A1	7/17/2003	Roesner et al.	257	233	

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
a		100 36 897 C1	1/2002	Germany	H01L	29/775		✓

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

aa	Engelhardt R. et al.: Growth of Compound Semiconductors in Nanometer Sized Channels of Polymers; Mat.Res.Soc.Symp.Proc. Vol. 672 (2201) pp 08.8.1 - 08.8.6

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.